

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF

Atty. Dkt.: 262732

ITO, et al.

Group Art Unit: Unknown

Appln. No.: /Unassigned

Examiner: Unknown

Filed: Herewith

FOR: METHOD OF ETCHING METALLIC THIN FILM ON THIN FILM  
RESISTOR



\* \* \* \* \*

July 28, 1999

**IDS LETTER CITING APPLICATION(S)  
AND ATTACHING PTO-1449/DOCUMENTS**

Hon. Commissioner of Patents  
and Trademarks  
Washington, D.C. 20231

Sir:

The Examiner's attention is directed to the following  
application(s) of:

Examiner's Initials*	FIRST INVENTOR (Last Name Only)	APPLICATION NO. (Series Code/Serial No.)
L. J. N-E.	OHKAWA	08/463,550 (refiled as 08/774,796)
L. J. N-E.	MIURA	08/885,192
L. J. N-E.	MIURA	09/315,132
L. J. N-E.	MIURA	08/965,030

**PLEASE DO NOT PRINT** the above information on the patent  
which results from the subject application.

Consideration of each listed application is earnestly  
solicited since unpublished patent applications are  
contemplated as IDS material; see the exception in Rule  
98(a)(2)(ii) and note the penultimate sentence of MPEP 609.

ITO, et al.

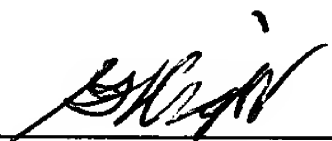
Further, in keeping with MPEP 609, Subsec. C(2), 2nd para., line 10 to end of the paragraph (especially note lines 18-25) **PLEASE RETURN A COPY OF THIS LETTER** with the Examiner's initials adjacent each above listing so that applicant will know that each listed application has been considered as required by PTO policy. Thanks.

Secondly, please consider each enclosed document which is listed on the attached Form PTO-1449 and return a copy of that form with the Examiner's initials adjacent each citation. Thanks again.

Respectfully submitted,

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\*The Examiner's initials adjacent a citation indicates he/she has considered the cited application relative to the subject application.